IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re p Taddi	atent application of: ken))
MMB	Docket No. 1890-0079) Examiner: To be assigned
Applic	eation No. 10/826,921) Group Art Unit: 2811
Filed:	April 16, 2004))
For:	Semiconductor Structure Having a Compensated Resistance in the LDD Area and Method for Producing the Same))))
		I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on November 9, 2004 (Date of deposit) James D. Wood Name of person mailing Document or fee
		November 9, 2004

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, Applicant hereby discloses the following references regarding the above-identified patent application.

Articles

1) Gebara, Edward, Niklas Rorsman, Jörgen Olsson, Herbert Zirath, Klas Håkan Eklund, "Output Power Characteristics of High Voltage LDMOS Transistors," Proceedings of the 5th Symposium on Gigahertz Electronics, Goeteborg, Sweden, March 2000, pages 75-78, (4 pages).

- 2) Disney, D. R., A. K. Paul, M. Darwish, R. Basecki, V. Rumennik, "A New 800V Lateral MOSFET With Dual Conduction Paths," Proceedings of the 13th International Symposium on Power Semiconductor Devices & ICs, Osaka, Japan, June 2001, pages 399-402, (4 pages).
- 3) Cai, Jun, Changhong Ren, N. Balasubramanian, Johnny K. O. Sin, "A Novel High Performance Stacked LDD RF LDMOSFET," IEEE Electron Device Letters, Vol. 22, No. 5, May 2001, (3 pages).
- 4) Söderbärg, A., B. Edholm, J. Olsson, F. Masszi and K. H. Eklund, "Integration of a Novel High-Voltage Giga-Hertz DMOS Transistor into a Standard CMOS Process," IEEE, 1995, pages 38.5.1-38.5.4, (4 pages).

"Output Power Characteristics of High Voltage LDMOS Transistors," "A New 800V Lateral MOSFET With Dual Conduction Paths," and "A Novel High Performance Stacked LDD RF LDMOSFET," were cited in a International Preliminary Examination Report (English translation enclosed) in a related Foreign patent application number PCT/EP02/09702 filed on August 30, 2002.

Pursuant to 37 C.F.R. § 1.97(b), this Information Disclosure Statement is being filed within three months after the filing date of the application or before the mailing of the first office action on the merits.

It is believed that no fees are due for the consideration of this Information Disclosure Statement. However, the Commissioner is hereby authorized to charge any deficiency or to credit any overpayment to Deposit Account No. 13-0014, but not to include any payment of issue fees.

November 9, 2004 Maginot, Moore & Beck Bank One Center Tower 111 Monument Circle, Suite 3000 Indianapolis, Indiana 46204-5115 (317) 638-2922 Respectfully Submitted,

James D. Wood Attorney for Applicant Registration No. 43,285 FORM PTO-1449

INFORMATION DISCLOSURE STATEMENT

MMB DOCKET NO. 1890-0079	APPLICATION NO.: 10/826,921		
APPLICANT(S): Taddiken			
FILING DATE: April 16, 2004	GROUP ART UNIT: 2811		

,		•		- T-				
•				U.S. PA	ATENT DOCUMENTS			
EXAMINER IŅITIAL		- 1	UMENT IBER	DATE	NAME	CLASS	SUB-CLASS	FILING DATE
	AA							
	AB							
-	AC							
	AD							
	AE		· · · · · · · · · · · · · · · · · · ·					
	AF							
	AG							
	АН							
	AI							
<u></u>	AJ							
	AK							
							<u></u>	
EXAMINER INITIAL		DOCUMENT NUMBER		DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION
	AL							Yes No
	AM							Yes No
	AN					V-1		Yes No
	AO							Yes No
.,	AP							Yes No
			ОТ	HER (Including Au	thor, Title, Date, Pertinen	t Pages, etc.)		
	AQ	Ī	Gebara, Edw of High Vo	ard, Niklas Rorsma	n, Jörgen Olsson, Herbert Zi sistors," Proceedings of the	irath, Klas Håkan E		
AR 1 Disney, D. R., A. K. Paul, M. Darwish, R. Basecki, V. Rumennik, "A New Conduction Paths," Proceedings of the 13 th International Symposium on Po Osaka, Japan, June 2001, pages 399-402, (4 pages).								
	AS	1	1		alasubramanian, Johnny K. evice Letters, Vol. 22, No. 5		•	ce Stacked LDD RF
EXAMINER	- I	1	 ,,			DATE C	CONSIDERED	
EXAMINER: conformance ar	Initial if r	eference sidered.	considered, v	whether or not citation of this form with ne	on is in conformance with Mext communication to Applie	IPEP 609. Draw lin cants.	ne through citatio	n if not in

FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT	MMB DOCKET NO. 1890-0079 APPLICATION NO.: 10/826,921			
•	APPLICANT(S): Taddiken			
	FILING DATE: April 16, 2004	GROUP ART UNIT: 2811		

				U.S	PATENT DOCUMENTS			
EXAMINER INITIAL		1	UMENT IBER	DATE	NAME	CLASS	SUB-CLASS	FILING DATE
	ВА							
•	ВВ							
	BC							
	BD							
	BE							
	BF							
	BG							
	ВН							
	BI							
	BJ							
	BK							
	,	 -						
EXAMINER INITIAL		DOC NUM	UMENT IBER	DATE	COUNTRY	CLASS	SUB-CLASS	TRANSLATION
	BL							Yes No
	ВМ							Yes No
	BN		· · · · · · · · · · · · · · · · · · ·					Yes No
	ВО							Yes No
	ВР							Yes No
			0	THER (Including	Author, Title, Date, Pertino	ent Pages, etc.)		110
	BQ	2	Söderbärg,	A., B. Edholm, J.	Olsson, F. Masszi and K. H. dard CMOS Process," IEEE,	Eklund, "Integration		-Voltage Giga-Hert
	BR	2						
_	BS	2			-11	· · · · · · · · · · · · · · · · · · ·		
EXAMINER		1				DATE	CONSIDERED	
EXAMINER:	Initial if	reference	considered	whether or not cit	tation is in conformance with h next communication to App	MPEP 609. Draw li	ne through citatio	n if not in